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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Chambers

Art Unit: 2829

Serial No.: 10/649,425

Examiner: Sarkar, A.

Filing Date: 08/27/2003

Docket No.: TI-35714

Customer No.: 23494

Conf. No.: 5169

Title: STRUCTURE AND METHOD TO FABRICATE SELF-ALIGNED TRANSISTORS  
WITH DUAL WORK FUNCTION METAL GATE ELECTRODES

## CERTIFICATION OF FACSIMILE TRANSMISSION

I hereby certify that the following papers are being transmitted by facsimile to the  
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Jacqueline J. Garner, Reg. No. 36,144April 20, 2005  
Date

## FACSIMILE COVER SHEET

<input checked="" type="checkbox"/> <b>FACSIMILE COVER SHEET</b>	<input checked="" type="checkbox"/> <b>AMENDMENT (10 Pages)</b>
<input type="checkbox"/> <b>NEW APPLICATION</b>	<input checked="" type="checkbox"/> <b>EOT 3mth (2 Pages)</b>
<input type="checkbox"/> <b>DECLARATION (# Pages)</b>	<input type="checkbox"/> <b>NOTICE OF APPEAL (# Pages)</b>
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<input type="checkbox"/> <b>CONTINUATION APP'N (# Pages)</b>	
<input type="checkbox"/> <b>DIVISIONAL APP'N</b>	
<b>NAME OF INVENTOR(S):</b> <b>Chambers</b>	
<b>TITLE OF INVENTION:</b> <b>STRUCTURE AND METHOD . . .</b>	
<b>TI FILE NO.:</b> <b>TI-35714</b>	<b>DEPOSIT ACCT. NO.:</b> <b>20-0668</b>
<b>FAXED: 4/20/2005</b> <b>DUE: 1/20/2005</b> <b>ATTY/SEC'Y: JJG</b>	
<b>RECEIPT DATE &amp; SERIAL NO.:</b> <b>Serial No.: 10/649,425</b> <b>Filing Date: 08/27/2003</b> <b>Conf. No.: 5169</b>	

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## AMENDMENT UNDER 37 CFR 1.111

Commissioner for Patents  
P.O. Box 1450  
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Trademark Office at (703) 872 - 9306 on 4/20/2005.

  
Jacqueline J. Garner  
Reg. No. 36,144

Dear Sir:

The following amendments and remarks are offered in response to the Examiner's Office Action dated 10/20/2004. They are respectfully submitted as a full and complete response to that Action.

Please amend the above-referenced application as follows:

There are no **Amendments to the Specification.**

**Amendments to the Claims** are reflected in the listing of claims that begin on page 2 of this paper.

There are no **Amendments to the Drawings.**

The **Remarks** begin on page 7.